

ATTENTION: BOX AFTER FINAL RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE REQUESTED EXAMINING GROUP 2814

PATENT Customer No. 22,852 Attorney Docket No. 04329.1952-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE		
In re Application of:	)	G. 56-4
Yoshitaka Tsunashima et al.	) Group Art Unit: 2814	3-5-03
Application No.: 09/688,989	) ) Examiner: S. Rao )	
Filed: October 17, 2000	) )	FEB -
For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	) ) )	ECEIVED FEB 12 2003
Assistant Commissioner for Patents Washington, DC 20231		R 2800

## REQUEST FOR RECONSIDERATION

In reply to the Final Office Action of November 8, 2002, the period for reply to which extends through February 10, 2003 (with February 8, 2003 being a Saturday), Applicants respectfully request reconsideration of the subject application for the following reasons.

## **REMARKS**

In the Final Office Action ("FOA"), the Examiner maintained the rejection of claims 27, 28, 30, and 32 under 35 U.S.C. § 112, first paragraph; maintained the rejection of claims 27, 28, and 30-33 under 35 U.S.C. § 112, second paragraph; and

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